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Attorney Docket No.: SEL 139 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shunpei Yamazaki et al.

Serial No.: 09/808,162

Filed: March 13, 2001

For: Method For Fabricating A
Semiconductor Device

Examiner: V. Simkovic

Art Unit: 2812

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 6/30/2003

Signature

Date

IN THE CLAIMS:

Please amend the claims as follows:

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13 (Amended). A method according to claim 1 further comprising the step of:

carrying out a second heat treatment at a temperature of not lower than 900°C.